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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| APPLICANT:  | YOUNG-HOON PARK                              | ) | Group Art Onit:              |  |
|-------------|--|---|------------------------------|--|
| SERIAL NO.: | 09/848,577                                   | ) |                              |  |
| FILED:      | May 3, 2001                                  | ) | Examiner:<br>Moore, Karla A. |  |
| FOR:        | REACTOR FOR DEPOSITING<br>THIN FILM ON WAFER | ) |                              |  |

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **AMENDMENT**

In response to Office Action mailed on March 18, 2004, the Applicant submits the following amendments and remarks for entry in the above-identified application.

09/848,577